

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on December 3, 1996.

Deborah T. Tomme

Deborah T. Tomme



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DEC 11 1996

GROUP 1100

Docket No. 0756-1398

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
 Takeshi FUKUNAGA et al.)
 Serial No. 08/519,420) Art Unit: 1112
 Filed: August 25, 1995) Examiner: M. Padgett
 For: A METHOD OF)
 MANUFACTURING A)
 SEMICONDUCTOR DEVICE)
 INCLUDING LASER)
 IRRADIATION FOLLOWED)
 BY THERMAL ANNEALING) December 3, 1996

Initial Review
BOX A/E

Assistant Commissioner for Patents
 Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment After Final Rejection and Request for Drawing Change Approval in the above-identified application.

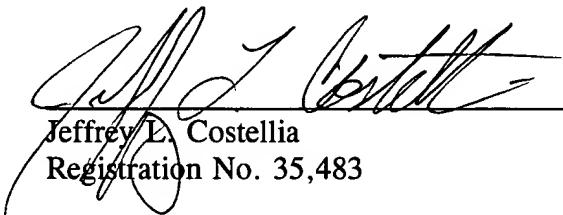
No additional claim fee is required.

	Claims Remaining After Amendment		Highest Number Previously Paid For	Present Extra	Small/Large Entity Rate	Fee
Total	21	Minus	22	-0-	x \$11/\$22	-0-
Indep.	8	Minus	8	-0-	x \$40/\$80	-0-
First Presentation of Multiple Dependent Claim					+ \$130/\$260	-0-
TOTAL						-0-

In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380 (0756-1398).

The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380 (0756-1398). A duplicate copy of this sheet is attached.

Respectfully submitted,



Jeffrey L. Costellia
Registration No. 35,483

Sixbey, Friedman, Leedom & Ferguson, P.C.
2010 Corporate Ridge, Suite 600
McLean, Virginia 22102
(703) 790-9110

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RESPONSE UNDER 37 CFR 1.116 - EXPEDITED

PROCEDURE - EXAMINING GROUP 1112

Initial Review
BOX AF

#9/B
(W.E.)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Takeshi FUKUNAGA et al.

Serial No. 08/519,420

Filed: August 25, 1995

For: A METHOD OF MANUFACTUR-

ING A SEMICONDUCTOR DEVICE

INCLUDING LASER IRRADIATION

FOLLOWED BY THERMAL

ANNEALING

) Examiner M. Padgett

) Art Unit 1112

)

)

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) Docket No. 0756-1398

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Deborah T. Tomme
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AMENDMENT AFTER FINAL REJECTION

Honorable Assistant Commissioner for Patents

BOX AF

Washington, D.C. 20231

Sir:

In response to the final rejection Office Action mailed September 3, 1996, please amend the above identified application as follows.

Do Not Enter the DPP 12/6/96